



*EFW/*

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Art Unit: 2815  
Examiner: Mr. Joseph H. Nguyen

In re PATENT APPLICATION of:

Applicant : Takashi NOGUCHI )

Serial No. : 10/822,691 )

Filed : April 13, 2004 )

For : HEAT RADIATION STRUCTURE )  
OF SEMICONDUCTOR DEVICE, )  
AND MANUFACTURING )  
METHOD THEREOF )

Atty Ref. : OKI 419 )

**PETITION FOR  
EXTENSION OF TIME**

\_\_\_\_\_  
August 22, 2006

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Please extend the period for responding to the Office Action of March 22, 2006  
by two months, and thus until August 22, 2006.

The \$450 extension fee is included in the remittance that is being submitted  
concurrently. Should this remittance be accidentally missing or insufficient, though, any  
fees that may be needed can be charged to our Deposit Account number 18-0002.

08/24/2006 MBERHE  
01 FC:1252

00000043 10022691

450.00 OP

Respectfully submitted,

*Allen Wood*

Allen Wood  
Registration No. 28,134  
Rabin & Berdo, P.C.  
Customer No. 23995  
(202) 326-0222  
(202) 408-0924 (facsimile)